

|     | Type | Hits  | Search Text  | DBs   | Time Stamp          |
|-----|------|-------|--|---|---------------------|
| 1   | BRS  | 0     | maskless adj<br>lithographic adj<br>pattern  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2005/11/21<br>10:57 |
| 133 | BRS  | 2     | "20050130351"  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/04/11<br>11:51 |
| 134 | BRS  | 5101  | exposure adj (cell<br>cells)   | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/04/11<br>12:01 |
| 135 | BRS  | 18    | ((mask?less) (without<br>near2 mask)) and<br>exposure adj (cell<br>cells)            | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/04/11<br>12:01 |
| 136 | BRS  | 16    | ("3932932" "4528072"<br>"5169805" "5432999"<br>"5577050" "5745673"<br>"5818748").pn. | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/04/11<br>11:59 |
| 137 | BRS  | 148   | shutter adj (cell<br>cells)  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/04/11<br>12:01 |
| 138 | BRS  | 34    | ((mask?less) (without<br>near2 mask)) and<br>shutter adj (cell<br>cells)             | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/04/11<br>12:01 |
| 139 | BRS  | 54252 | (electron electrons<br>cells cells) with<br>(thick thickness)                        | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/05/30<br>08:20 |
| 140 | BRS  | 11984 | (electron electrons<br>cells cells) with<br>(thick thickness) same<br>substrate      | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/05/30<br>08:21 |

|     | Type | Hits | Search Text  | DBs   | Time Stamp          |
|-----|------|------|--|---|---------------------|
| 141 | BRS  | 168  | (lithograph\$3) with<br>(electron electrons<br>cells cells) with<br>(thick thickness) same<br>substrate  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/05/30<br>08:21 |
| 142 | BRS  | 351  | (lithograph\$3) same<br>(electron electrons<br>cells cells) with<br>(thick thickness) same<br>substrate  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/05/30<br>08:21 |
| 143 | BRS  | 259  | (lithograph\$3) same<br>(electron electrons<br>cells cells) with<br>(thick thickness) same<br>substrate and mask                                   | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/05/30<br>08:21 |
| 144 | BRS  | 238  | (lithograph\$3) same<br>(electron electrons<br>cells cells) with<br>(thick thickness) same<br>substrate and mask and<br>pattern                    | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/05/30<br>08:21 |
| 145 | BRS  | 85   | (lithograph\$3) same<br>(electron electrons<br>cells cells) with<br>(thick thickness) same<br>substrate same<br>(expos\$4) and mask and<br>pattern | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/05/30<br>08:22 |
| 146 | BRS  | 2691 | direct adj write   | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/05/30<br>08:37 |
| 147 | BRS  | 306  | direct adj write adj<br>lithograph\$3  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/05/30<br>08:38 |
| 148 | BRS  | 120  | direct adj write adj<br>lithograph\$3 and x?ray  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/05/30<br>08:39 |

|     | Type | Hits | Search Text   | DBs   | Time Stamp          |
|-----|------|------|---|---|---------------------|
| 149 | BRS  | 35   | direct adj write adj<br>lithograph\$3 and SLV   | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/05/30<br>08:38 |
| 150 | BRS  | 35   | direct adj write adj<br>lithograph\$3 and SLV<br>and RSC  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/05/30<br>08:39 |
| 151 | BRS  | 186  | direct adj write adj<br>lithograph\$3 and<br>radiation  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/05/30<br>08:39 |
| 152 | BRS  | 81   | direct adj write adj<br>lithograph\$3 and<br>radiation with<br>(electron electrons<br>cell cells)           | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/05/30<br>08:40 |
| 153 | BRS  | 57   | direct adj write adj<br>lithograph\$3 and<br>radiation with<br>(electron electrons<br>cell cells) and x?ray | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2006/05/30<br>08:40 |